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Substitute for form 1449B/PTO				Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT				Application Number	10/813,026
				Filing Date	March 31, 2004
				First Named Inventor	GINSBURG, Eyal
				Group Art Unit	4742 2817
(use as many sheets as necessary)				Examiner Name	Not yet known <i>Barbara Summons</i>
Sheet	2	of	2	Attorney Docket Number	P-6640-US

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Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (where appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
BS	C	Fukang J. et al., "A Flexible MEMS Technology and its First Applications to Shear Stress Sensor Skin", Micro Electro Mechanical Systems, 1997, MEMS 97, Proceedings, IEEE, Tenth Annual International Workshop on Nagoya, Japan, 26-30 JAN. 1997, New York, NY, USA, IEEE, 26 January 1997, pp. 465-470	<input type="checkbox"/>
BS	D	Lutsky J.J. et al., "A sealed cavity TFR process for RF bandpass filters", Electron Devices Meeting, 1996, International San Francisco, CA, USA, 8-11 DEC. 1996, New York, NY, USA, IEEE, USA, 08 December 1996, pp. 95-98	<input type="checkbox"/>
BS	E	Copy of International Search Report for PCT/US2005/006721, mailed on 29 June 2005	<input type="checkbox"/>
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Sheet	1	of	1

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BS	A	"IEEE ELECTRON DEVICE LETTERS", VOL. 21, NO. 12, DECEMBER 2000, 2 pages	<input type="checkbox"/>
BS	B	Kohl et al., "Air-gaps in 0.3 µm Electrical Interconnections", IEEE Electron Device Letters, Vol. 21, No. 12, December 2000, pp. 557-559	<input type="checkbox"/>
BS	C	Tsamis et al., "Fabrication of Suspended Porous Silicon Micro-hotplates for Thermal Sensor Applications", Porous Silicon Science and Technology Conference, PSST 2002, 10-15 March 2002, Tenerife, Spain, pp. 1-13	<input type="checkbox"/>
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